

LIST OF ART CITED BY APPLICANT 			ATTY. DOCKET NO. K-0625		APPLN. SERIAL NO. 10/804,235	
			APPLICANT(S) Jin Woong KIM et al.,			
			FILING DATE March 19, 2004		GROUP 1746	
			U.S. PATENT DOCUMENTS			
EXAMINER'S INITIALS	PATENT NO.	*ISSUE DATE	*INVENTOR NAME	CLASS	SUBCLASS	FILING DATE
/JLP/	7,096,695	08/2006	No et al.	68	58	
	6,889,399	05/2005	Steiner et al.	81	159	
	5,782,111	07/1998	Sights et al.	68	142	
	3,946,500	03/1976	Barrett et al.	34	139	
↓	2,480,929	09/1949	Hyman Sam M	34	108	
	2,305,695	12/1942	Bittick Hayes Saviere	68	60	
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/JLP/	2005/0217035	10/2005	Steiner et al.	008	149.3	
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EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation
/JLP/	1999-85001	06/12/1999	Korea (English Abstract & Full Korean Text)			X
	09-215894	08/19/1997	Japan (English Abstract & Full Japanese Text & Electronic Translation)			X
	KR 2004/022991	03/2004	Korea (English Abstract & Full Korean Text)			X
↓	DE 537758	11/1931	Germany (Electronic Translation)			X
OTHER ART (Including Author, Title, Date, Pertinent Pages, Publisher, Place of Publication, Etc.)						
EXAMINER	DATE CONSIDERED					
Joseph L. Perrin/				07/07/2007		

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.\\\Fk4\Documents\2016\2016-754\120629.doc